

Notice of References Cited		Application/Control No.	Applicant(s)/Patent Under Reexamination LU ET AL.	
		Examiner Nira S. Birenbaum	Art Unit 1742	Page 1 of 1

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*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
A	US-6,344,411	02-2002	Yamada et al.	438/653
B	US-			
C	US-			
D	US-			
E	US-			
F	US-			
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I	US-			
J	US-			
K	US-			
L	US-			
M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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	V	Mattox, D.M. "Thin Films, Film Formation Techniques." Kirk-Othmer Encyclopedia of Chemical Technology 1997. Accessed online. DOI: 10.1002/0471238961.0609121313012020.a01
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	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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